





IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

AUG 21 2002

TECHNOLOGY CENTER 2800

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Applicants

Hiroyuki Yano et al.

U.S. Serial No.

09/870,085

Filing Date

May 30, 2001

For

MANUFACTURING METHOD OF SEMICONDUCTOR

DEVICE

Examiner

Thanhha Pham

Group Art Unit

2813

745 Fifth Avenue

New York, New York 10151

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, DC 20231, on.

Name of Applicant, Assignee or Registered Representative

July 30, 2002

Date of Signature

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

The Examiner's attention is respectfully invited to review the following enclosed and listed document which is also listed on the accompanying Form PTO-1449, enclosed in duplicate.

08/23/2002 JMCMILLA 00000006 500320

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180.00 CH

FOREIGN PATENT

Japanese Unexamined Patent Publication Tokukai Sho. 62-154614

Published: July 9, 1987 to Imaoka et al.

This Information Disclosure Statement is not a representation that the document cited herein is considered most pertinent, or that a search has been undertaken, or that any of the cited document is indeed prior art. The Examiner is invited to undertake an independent search.

Applicants assert that the claimed invention is patentable over this document.

Applicants respectfully request that the Examiner consider and make of record the document cited herein and that a copy of Form PTO-1449, appropriately initialed by the Examiner, be returned to Applicants' attorney.

It is believed no fee is due, however, the Examiner is authorized to charge any deficit or credit any overpayment to Deposit Account No. 50-0320.

Respectfully submitted,

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